

Docket: 740819-640

1c978 U.S. PRO  
09/942907  
08/31/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of ) *a / IDS*  
Tsuneo IKURA ) *E. Millio*  
Japanese Priority Application No. 2000-362300 ) *12-3-01*  
Japanese Priority Date: November 29, 2000 ) Attn: Applications  
For: METHOD FOR FABRICATING ) Branch  
SEMICONDUCTOR DEVICE ) Date: August 31, 2001

INFORMATION DISCLOSURE STATEMENT

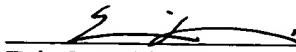
Honorable Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

  
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